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| Priority Application Serial No |
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| Priority Filing Date April 10, 1998 |
| Inventor Vishnu K. Agarwal et al. |
| Assignee |
| Assignee Micron Technology, Inc. Priority Group Art Unit 2822 |
| Priority Examiner M. Guerrero |
| Attorney's Docket No MI22-1299 |
| Title: Capacitors and Methods of Forming Capacitors |

PRELIMINARY AMENDMENT

To: **BOX PATENT APPLICATION**

Assistant Commissioner for Patents

Washington, D.C. 20231

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Please enter the following amendments prior to examining the above-identified application.

AMENDMENTS

In the Specification

At p. 1 before the "Technical Field" section, please insert the following:

--RELATED PATENT DATA

This application resulted from U.S. Patent Application Serial No. 09/059,057, filed April 10, 1998, entitled "Capacitors and Methods of

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